FORM PTO-1419

US DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE

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To be Assigned

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Applicant:

Barry D. Silverstein, et al

LIST OF ART CITED BY APPLICANT

Filing Date

	(Use several sheets	if necessary)	Herewith 03/	30/2004	To	be <del>Assigned</del>
		<del>-</del>	U.S. PATENT DOCUMENTS			
Examiner Initial*	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
.R.C]	4,441,791	4/10/84	Hornbeck	359	295	
	5,535,047	7/9/96	Hornbeck	359	295	
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$\neg \vdash$	6,010,121	1/4/00	Lee	269	94	
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EXAMINER TO CONSIDERED 12/14/05							
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609: Draw line through citation if not in conformance  and not considered. Include copy of this form with lasts communication to applicant.							